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INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)				APPLICANT Jose Arno			
				FILING DATE September 26, 2002		GROUP 2812 1753	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	5,565,038	10/15/1996	Ashley	134	2		
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES NO
							X (abstract only)
OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)							
AB	Y. Saito, et al., "Plasmaless Cleaning Process of Silicon Surface Using Chlorine Trifluoride", Applied Physics Letters, Vol. 56(8), pp. 1119-1121 (1990) 10 month						
AC	D.E. Ibbotson, et al., "Plasmaless Dry Etching of Silicon with Fluorine-Containing Compounds", Journal of Applied Physics, Vol. 56(10), pp. 2939-2942 (1984) no month						
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EXAMINER Sama Wang					DATE CONSIDERED 12/8/03		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							